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SERIAL NUMBER 10/648,172	FILING DATE 08/25/2003 RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 51876P377
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APPLICANTS

Sung-Kwon Lee, Ichon-shi, KOREA, REPUBLIC OF;

** CONTINUING DATA ***** *none* *K-CC*

** FOREIGN APPLICATIONS ***** *K-CC*

REPUBLIC OF KOREA 2002-85131 12/27/2002
 REPUBLIC OF KOREA 2002-86489 12/30/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 11/15/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>K-CC</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 12	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 3
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ADDRESS
 08791
 BLAKELY SOKOLOFF TAYLOR & ZAFMAN
 12400 WILSHIRE BOULEVARD
 SEVENTH FLOOR
 LOS ANGELES , CA
 90025-1030

TITLE
 Method for fabricating semiconductor device using ArF photolithography capable of protecting tapered profile of hard mask

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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